



28/11/06

PATENT
Customer No. 22,852
Attorney Docket No. 03180.0278

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ryoichi INANAMI et al.

Application No.: 09/817,270

Filed: March 27, 2001

For: EXPOSURE PATTERN DATA GENERATION
APPARATUS ASSOCIATED WITH STANDARD
CELL LIBRARY AND CHARGED BEAM
EXPOSURE

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)
) Group Art Unit: 2881

)
) Examiner: Phillip A. Johnston

)
)
) Confirmation No.: 7690

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

07/27/2006 SDEHBOB1 00000031 09817270
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Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(d)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(d), Applicants bring to the attention of the Examiner the documents on the attached listing. This Information Disclosure Statement (IDS) is being filed after a Final Action and is accompanied by a fee of \$180.00 as specified under § 1.17(p) and a certification as specified under § 1.97(e). Copies of the listed foreign patent documents are attached.

Applicants respectfully request that the Examiner consider the listed documents and indicate that they were considered by making appropriate notations on the attached form.

The documents listed in this IDS were first cited in a Notification of Reasons for Refusal ("Notification") from the Japanese Patent Office in a counterpart foreign application, and this IDS is being filed within three months of the mailing date of that communication.

In lieu of a statement of relevance or translation of the listed non-English documents, an English language translation of the Notification citing these documents and setting forth the

relevance thereof is enclosed. A copy of the Notification is also enclosed for the Examiner's convenience. Applicants do not necessarily endorse the conclusions set forth in the Notification.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claims in the application and Applicants determine that the cited documents do not constitute "prior art" under United States law, Applicants reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

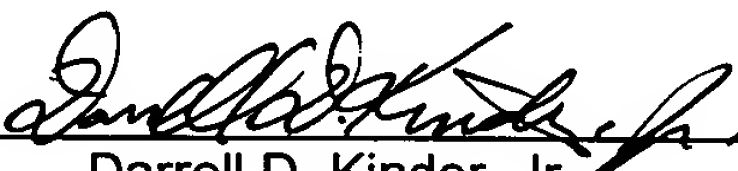
Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

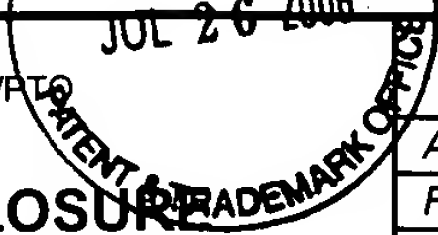
If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: July 26, 2006

By: 
Darrell D. Kinder, Jr.
Reg. No. 57,460



IDS Form PTO/SB/08: Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known

Application Number	09/817,270
Filing Date	March 27, 2001
First Named Inventor	Ryoichi INANAMI
Art Unit	2881
Examiner Name	Phillip A. Johnston
Attorney Docket Number	03180.0278

Sheet

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U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite No. ¹	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
		US-			
		US-			
		US-			

Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
		JP 05-182899	07-23-1993	Fujitsu Ltd.		Abstract
		JP 05-234860	09-10-1993	Hitachi, Ltd.		Abstract
		JP 09-312253	12-02-1997	Hitachi, Ltd.		Abstract
		JP 10-209001	08-07-1998	Agency of Ind. Science & Technology		Abstract
		JP 11-040485	02-12-1999	Hitachi, Ltd.		Abstract
		JP 2000-058424	02-25-2000	NEC Corp.		Abstract
		JP 2001-117214	04-27-2001	Semiconductor Leading Edge Technologies Inc.		Abstract
		JP 2001-143989	05-25-2001	Fujitsu Ltd.		Abstract
		PCT WO 01/41198 A1	06-07-2001	Hitachi, Ltd.		Abstract
		JP 2001-267223	09-28-2001	Hitachi, Ltd.		Abstract
		JP 06-168869	06-14-1994	Hitachi, Ltd.		Abstract

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁶
		Notification of Reason for Refusal from the Japanese Patent Office, mailed June 27, 2006, in Japanese Patent Application No. 2000-087930, and English translation thereof	YES

Examiner Signature		Date Considered	
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.